Docket No.: P16666

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

n re th	e Patent Application of:)
Shriram Ramanathan et al.))
Serial N	No.: 10/611,395) Confirmation No.: 1525
Filed:	June 30, 2003) Examiner: Heather Anne Dot
	METHODS FOR BONDING WAFERS USING A) Art Unit: 2813)
	METAL INTERLAYER))

RESPONSE TO OFFICE ACTION

Mail Stop: Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 INTRODUCTORY COMMENTS

Sir:

This paper is being filed in response to an Office Action having a mailing date of April 17, 2007 that Applicant has received from the Patent Office and that relates to the above-identified patent application. Applicant respectfully requests that the patent application be reconsidered in view of the amendments and remarks presented hereinafter, which are submitted as a full and complete response to the aforementioned Office Action

This paper is timely filed upon the mailing of same with an executed certificate of mailing on or before July 17, 2007. No fees are believed to be due by virtue of the filing of this paper. However, if it is determined that any fees are in fact due, please charge such fees to Deposit Account No. 50-0221.

Claims 1-5, 7-20, and 22-27 remain in the subject patent application. Claims 1, 12, 13, and 27 are amended and claims 6 and 21 are canceled herein. Claims 28-42 were canceled in an earlier paper. No claims are added herein.